

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Warren M. Farnworth

Serial No.: 10/663,944

Filed: September 16, 2003

For: STEREOLITHOGRAPHIC METHOD
FOR FORMING INSULATIVE COATINGS
FOR VIA HOLES IN SEMICONDUCTOR
DEVICES, INSULATIVE COATINGS SO
FORMED, SYSTEMS FOR FORMING THE
INSULATIVE COATINGS, AND
SEMICONDUCTOR DEVICES

Confirmation No.: 3861

Examiner: William M. Brewster

Group Art Unit: 2826

Attorney Docket No.: 2269-5700US
(02-1183.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 9, 2004
Date

Signature

Denise Dyer
Name (Type/Print)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 or PTO/SB/08 be considered by the Examiner and made of record. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicant herein that no other possible material information as defined in 37 C.F.R. § 1.56 (b) exists.

Other Documents

MILLER et al., "Makelss Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22.

MILLER et al., "New Laser-Directed Deposition Technology", Microelectionic Fabrication, August 2001, page 16.

Webpage, Object Prototyping the Future, "Object FullCure 700 Series", 1 page.

Webpage, Objet Prototyping the Future, "How it Works", 2 pages.

Applicant offers to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

Serial No. 10/663,944

This Supplemental Information Disclosure Statement is filed after the mailing date of the first Office Action on the merits.

The fee pursuant to 37 C.F.R. § 1.17(p) is enclosed.

Respectfully submitted,



Brick G. Power
Registration No. 38,581
Attorney for Applicant(s)
TRASKBRITT
P.O. Box 2550
Salt Lake City, Utah 84110-2550
Telephone: 801-532-1922

Date: November 9, 2004
BGP/djp:dd

Enclosures: Form PTO-1449 or PTO/SB/08
Copy of documents cited
Check No. 6918 in the amount of \$180.00

Document in ProLaw

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT***(use as many sheets as necessary)*

Sheet

1

of

1

Complete if Known

Application Number

10/663,944

Filing Date

September 16, 2003

First Named Inventor

Warren M. Farnworth

Group Art Unit

2826

Examiner Name

William M. Brewster

Attorney Docket Number

2269-5700US (02-1183.00/US)

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		MILLER et al., "Makelss Mesoscale Materials Deposition", Deposition Technology, September 2001. pages 20-22.	
		MILLER et al., "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16.	
		Webpage, Objet Prototyping the Future, "Obect FullCure 700 Series", 1 page.	
		Webpage, Objet Prototyping the Future, "How it Works", 2 pages.	

Examiner
Signature

Date

Considered

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.